

Notice of References Cited	Application/Control No. 10/688,711		Applicant(s)/Patent Under Reexamination REN ET AL.	
	Examiner Cephia D. Toomer		Art Unit 1714	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,864,001	03-2005	Zhang et al.	429/15
*	B	US-6,604,598	08-2003	Rohde et al.	180/271
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
X	N	JP2001-093558	04-2001	Japan		
	O	WO0021772	04-2000	WIPO		
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.